



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Akira ISHIKAWA

Application No. 10/670,310

Filed: September 26, 2003

For: MANUFACTURING METHOD OF
SEMICONDUCTOR DEVICE

)

) Group Art Unit: 2823

) Examiner: Malsawma, Lalrinfamkim Hmar

) Confirmation No. 5329

) May 9, 2005

AMENDMENT AFTER FINAL

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed February 8, 2005, please amend the above identified application as follows.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.